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APPLICANTS

Sung Hoon Lee, Seoul, KOREA, REPUBLIC OF;

** CONTINUING DATA ***** NAME LV

** FOREIGN APPLICATIONS ***** VER LV
 REPUBLIC OF KOREA 2002-68678 11/07/2002

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged	 Examiner's Signature	LV Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4	TOTAL CLAIMS 11	INDEPENDENT CLAIMS 1
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ADDRESS
 04743
 MARSHALL, GERSTEIN & BORUN LLP
 233 S. WACKER DRIVE, SUITE 6300
 SEARS TOWER
 CHICAGO , IL
 60606

TITLE
 Method of forming an isolation film in a semiconductor device

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